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(12) **United States Design Patent**
Ishikawa et al.

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(54) **LID ASSEMBLY FOR A SUBSTRATE
PROCESSING CHAMBER**

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(**) Term: **14 Years**

(21) Appl. No.: **29/358,979**

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(51) **LOC (9) Cl.** **15-01**

(52) **U.S. Cl.** **D15/144.1**

(58) **Field of Classification Search** D10/46;
D15/122, 144.1; 118/723 DC, 723 E, 723 ER,
118/723 IR, 723 R, 715, 69; 134/8; 156/345.43,
156/345.35, 345.45; 428/64.1

See application file for complete search history.

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(57) **CLAIM**

The ornamental design for a lid assembly for a substrate
processing chamber, as shown and described.

DESCRIPTION

FIG. 1 is a top plan view of a lid assembly for a substrate
processing chamber showing our new design.

FIG. 2 is a side elevation view of the lid assembly of FIG. 1 as
viewed from line FIG. 2 of FIG. 1.

FIG. 3 is a side elevation view of the lid assembly of FIG. 1 as
viewed from line FIG. 3 of FIG. 1.

FIG. 4 is a side elevation view of the lid assembly of FIG. 1 as
viewed from line FIG. 4 of FIG. 1.

FIG. 5 is a side elevation view of the lid assembly of FIG. 1,
rotated 180°, as viewed from line FIG. 5 of FIG. 1.

FIG. 6 is an isometric top view of the lid assembly of FIG. 1.

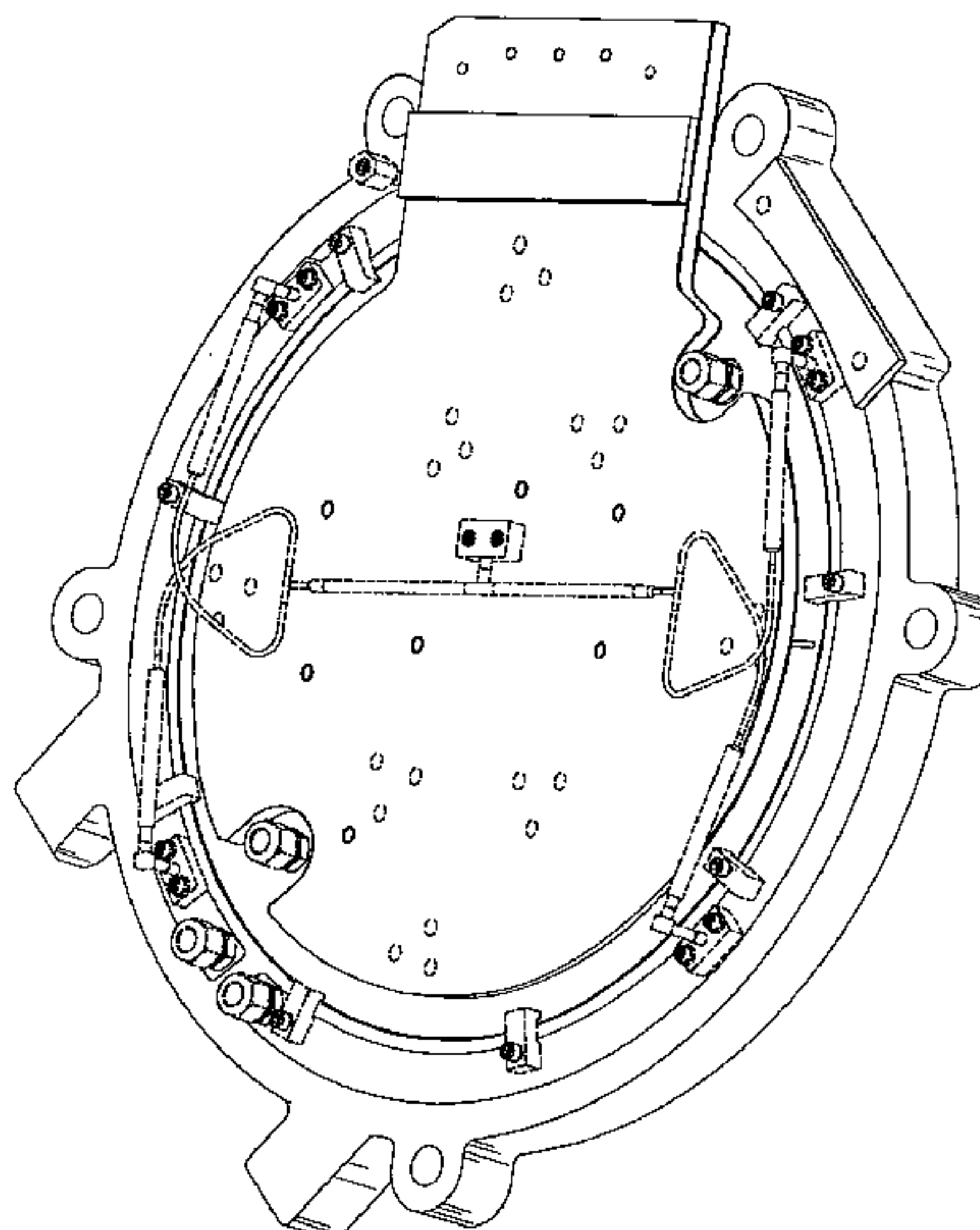
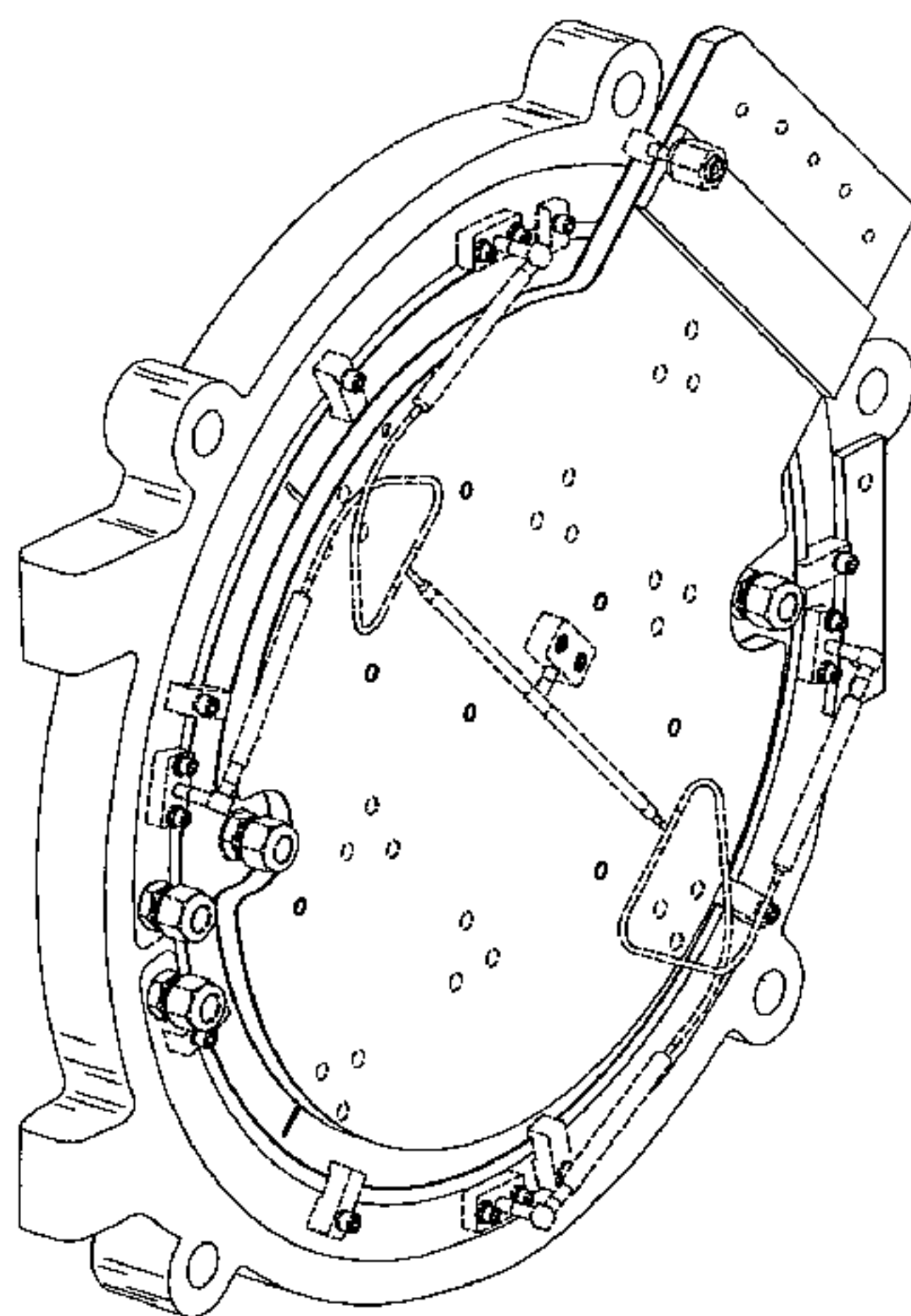
FIG. 7 is another isometric top view of the lid assembly of
FIG. 1.

FIG. 8 is an isometric bottom view of the lid assembly of FIG.
1; and,

FIG. 9 is a bottom plan view of the lid assembly of FIG. 1.

The broken line showing of structural features is included for
the purpose of illustrating non-claimed subject matter and
forms no part of the claimed design.

1 Claim, 9 Drawing Sheets



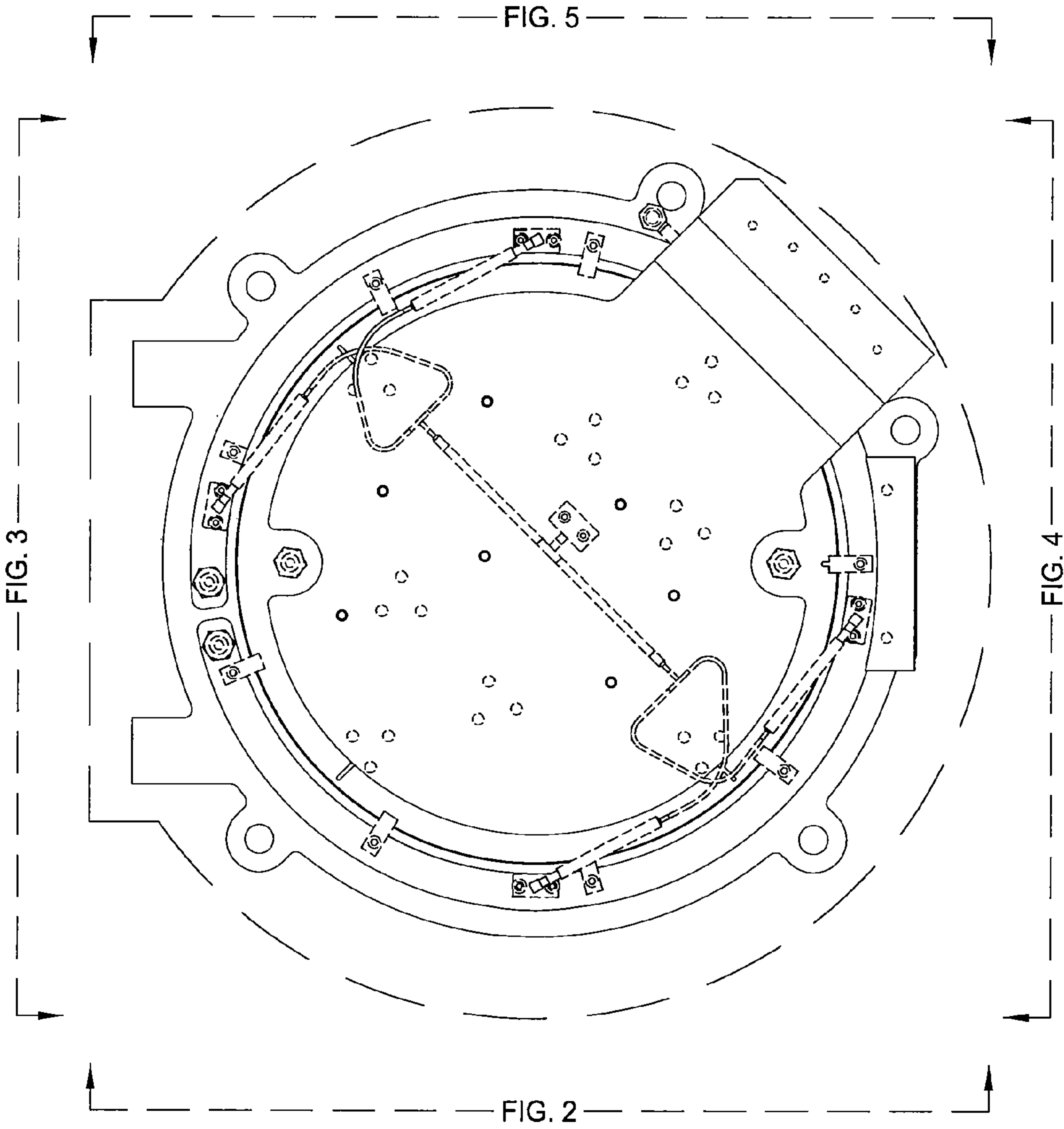


FIG. 1

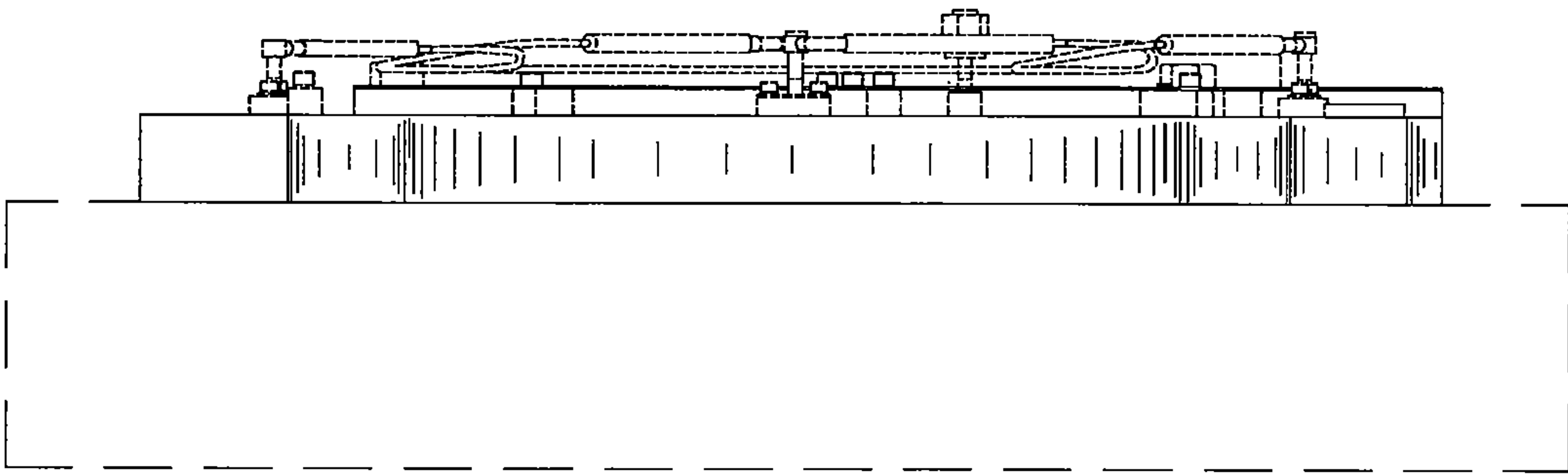


FIG. 2

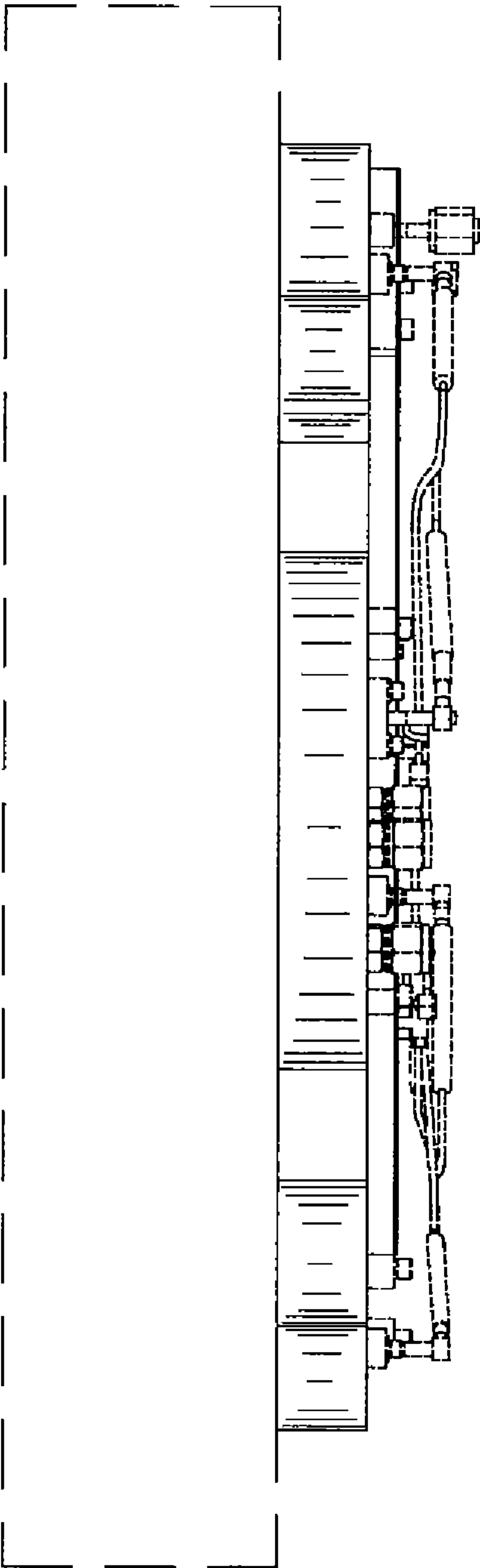


FIG. 3

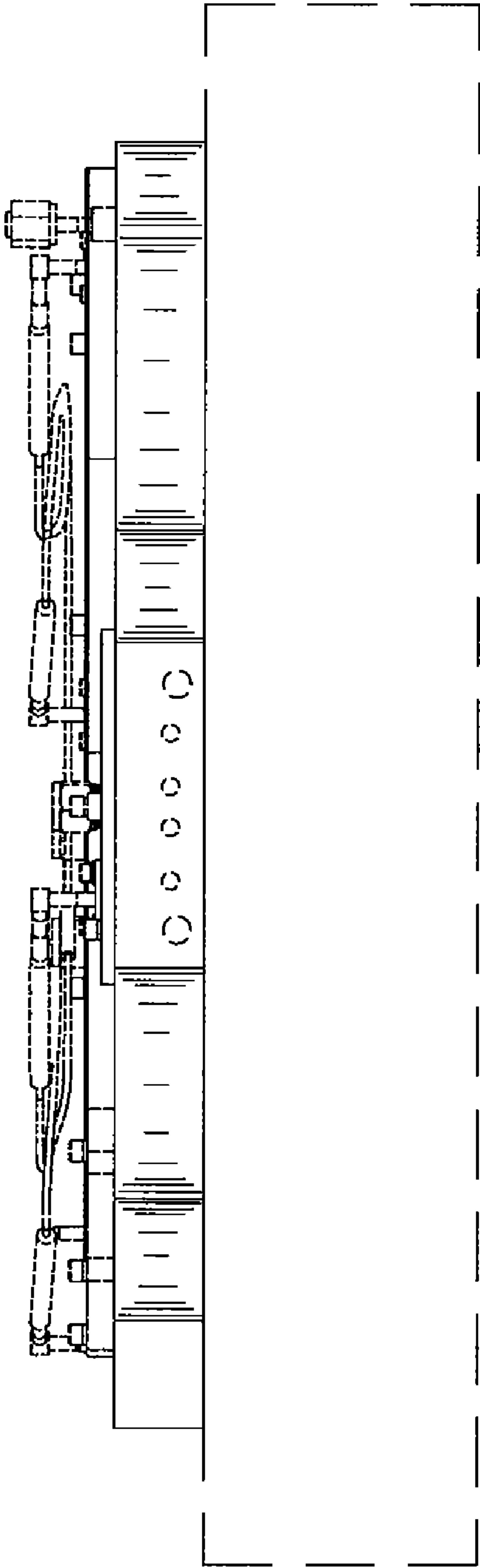


FIG. 4

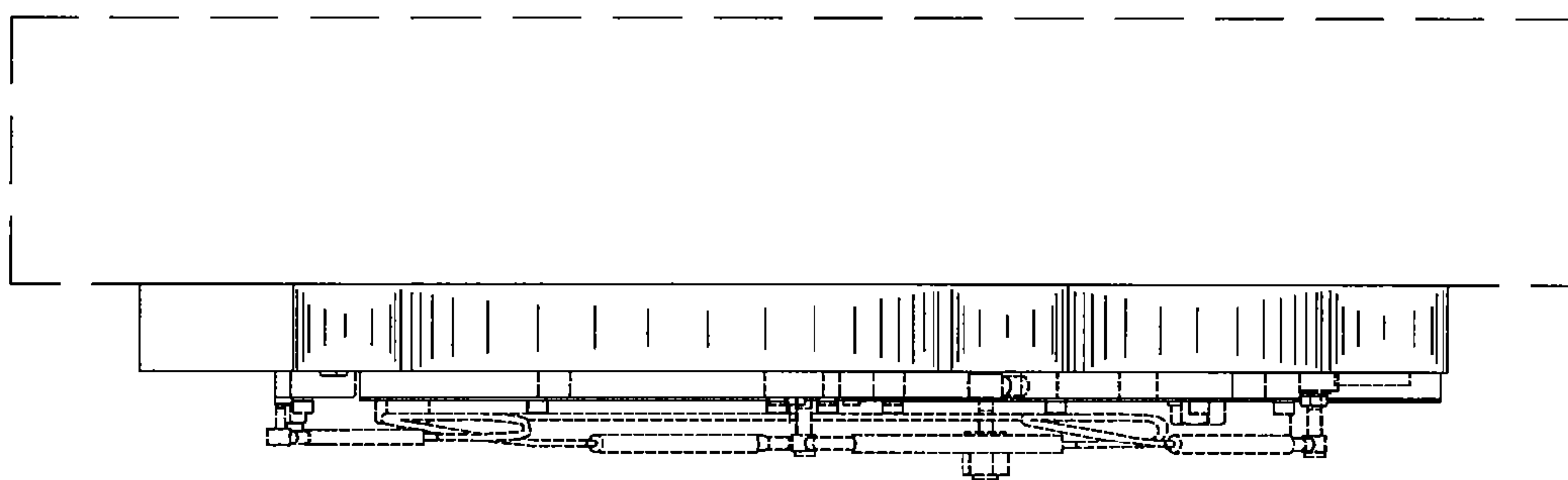


FIG. 5

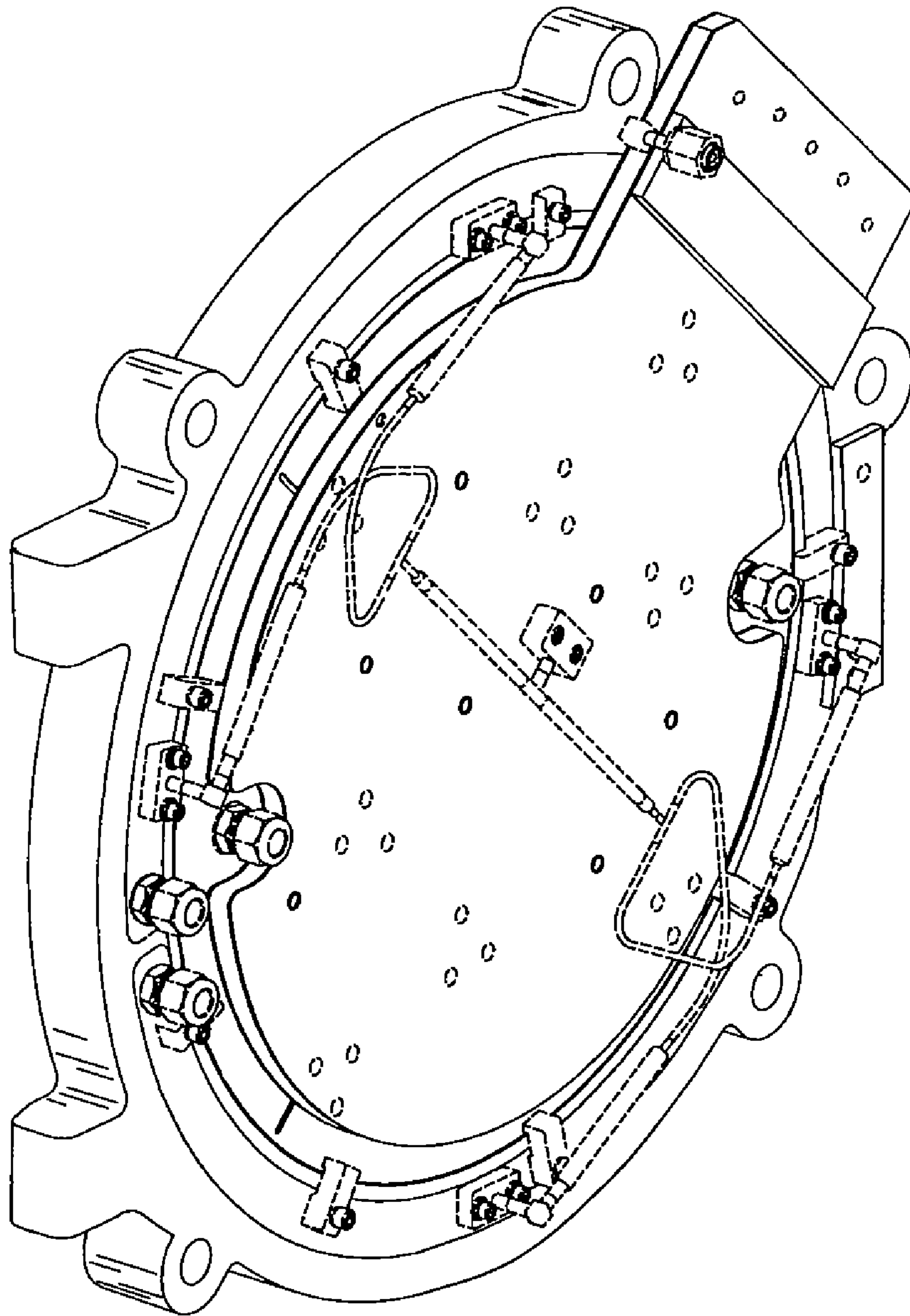


FIG. 6

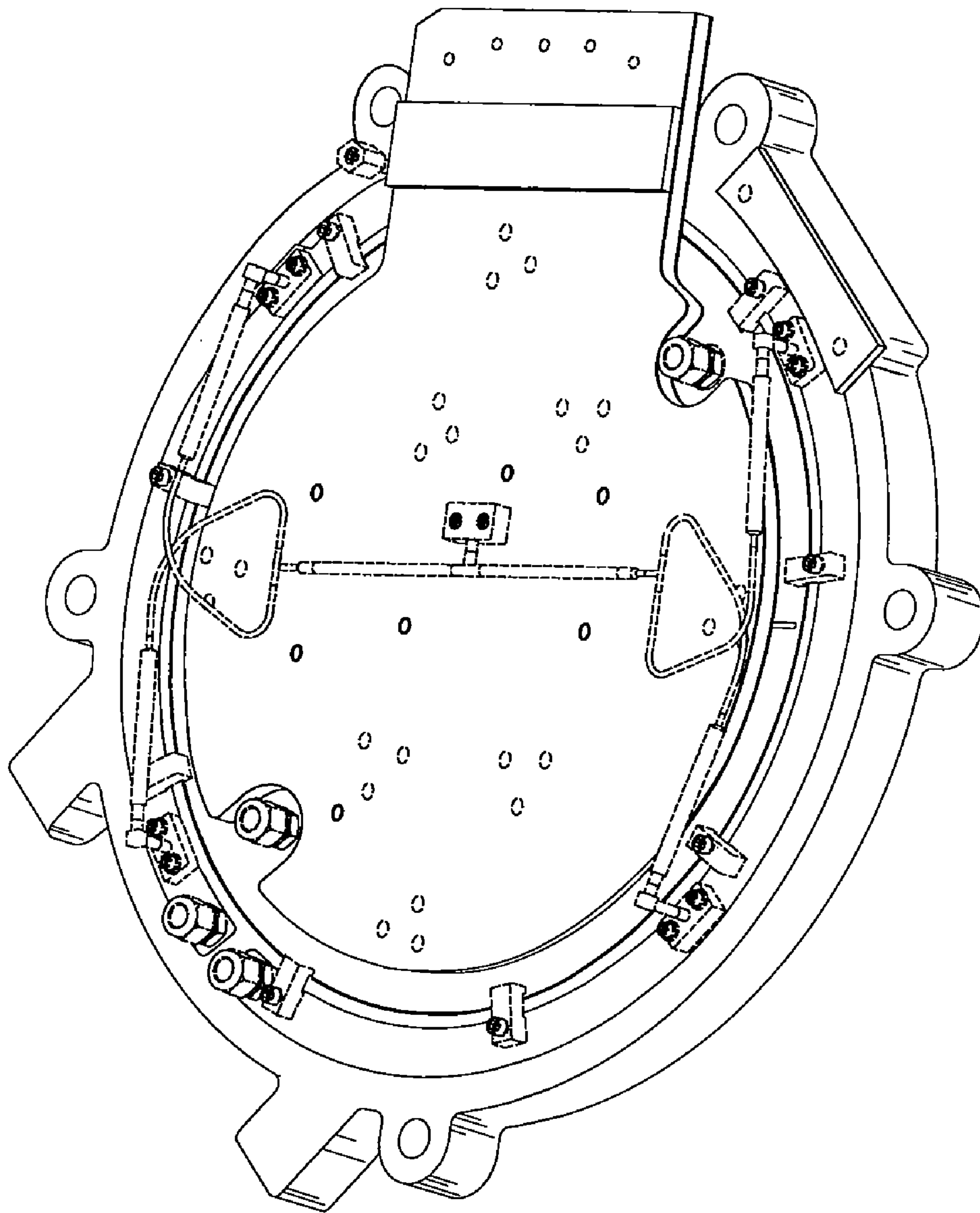


FIG. 7

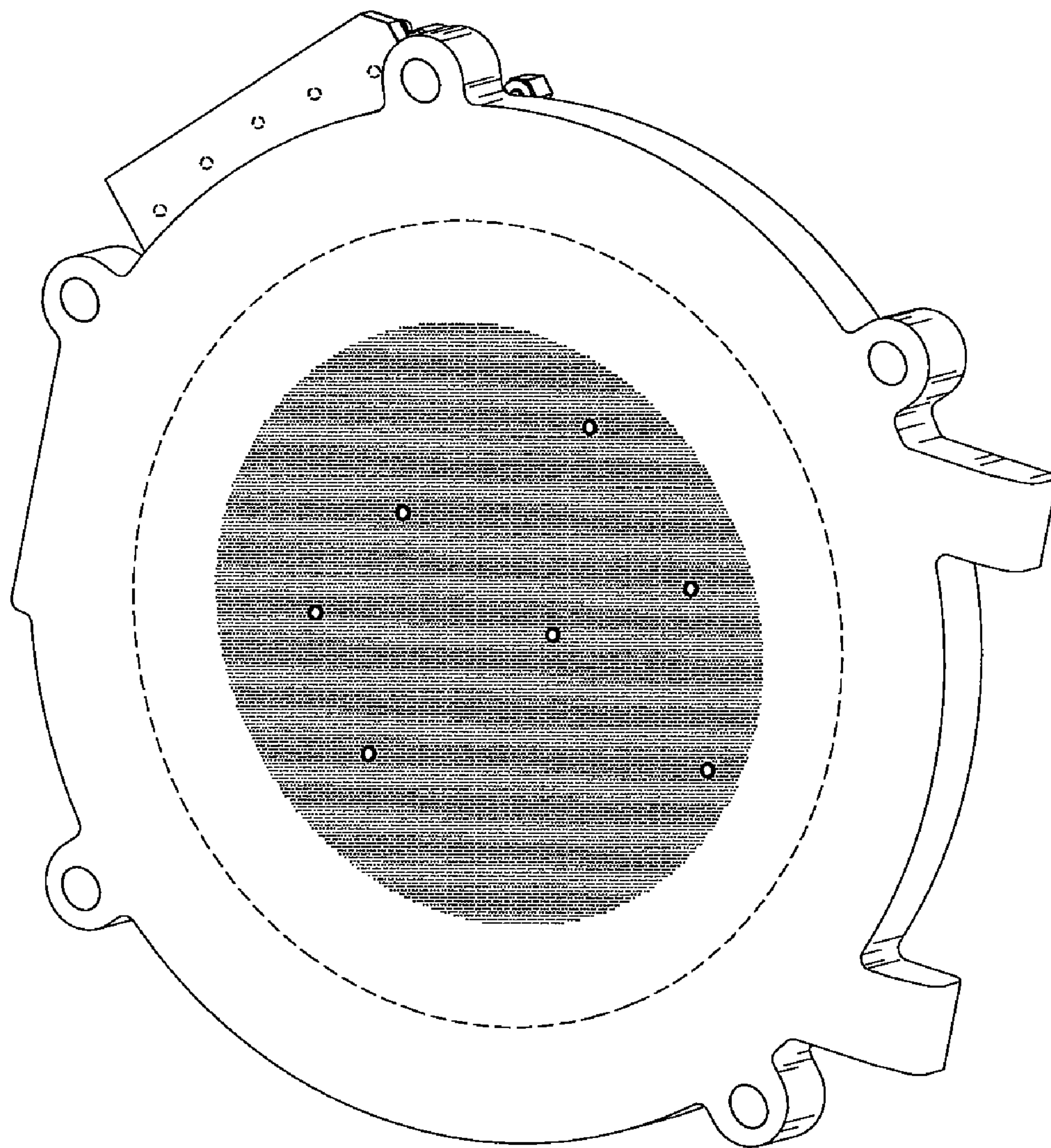


FIG. 8

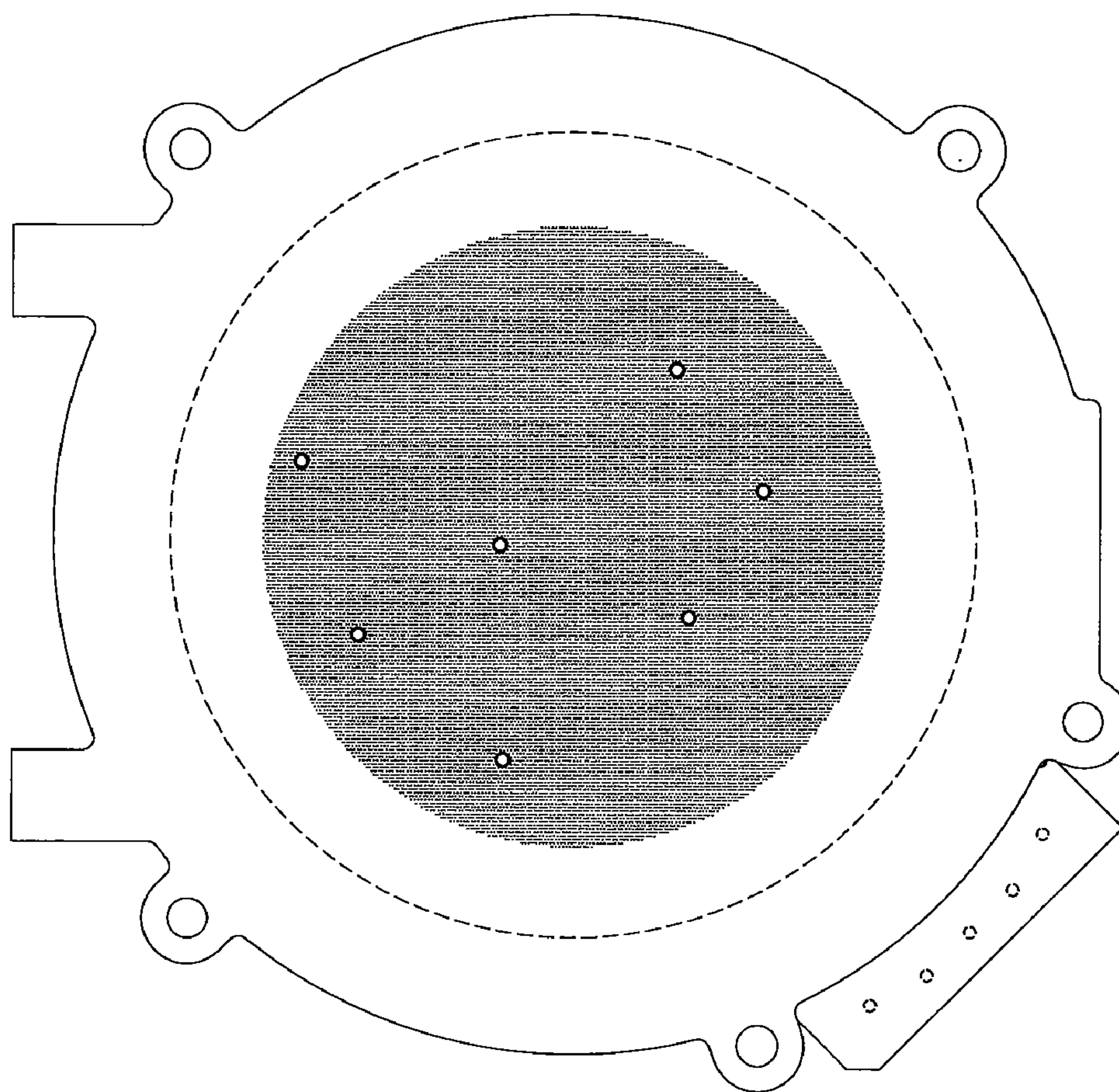


FIG. 9